

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q83324

Kenji YAKUSHIJI

Appln. No.: 10/573,017

Group Art Unit: 4174

Confirmation No.: 2532

Examiner: Shizhi CHEN

Filed: January 19, 2007

For: METHOD FOR FABRICATION OF SEMICONDUCTOR LIGHT-EMITTING DEVICE  
AND THE DEVICE FABRICATED BY THE METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 21, 2008, please amend the above-identified application as follows on the accompanying pages.

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